

Notice of References Cited	Application/Control No. 09/803,715	Applicant(s)/Patent Under Reexamination LI, JIA	
	Examiner Julio J. Maldonado	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,110,899	09-1978	Nagasawa et al.	438/227
*	B	US-5,169,792	12-1992	Kato et al.	257/398
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	L	US-			
	M	US-			

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*	N	JP 63-271956	09-1998	JP	Hosaka	H 01L 21/76
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Silicon Processing for the VLSI Era, Volume 2, 1990 by Lattice Press, pages 38-41
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.